

AGILENT TECHNOLOGIES, INC.
Legal Department, DL429
Intellectual Property Administration
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2021
PATENT APPLICATION

ATTORNEY DOCKET NO. 10021136-1

IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Inv ntor(s): Theil, et al

Serial No.: 10/615522

Examiner: Unassigned

Filing Date: 07/08/2003

Group Art Unit: 2621

Title: Reducing Image Sensor Lag

COMMISSIONER FOR PATENTS
PO Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

- (X) under 37 CFR 1.97(b), or
(Within three months of filing national application; or date of entry of national application; or before mailing date of first office action on the merits; whichever occurs last)
- () under 37 CFR 1.97(c) together with either a:
() Statement under 37 CFR 1.97(e), or
() a \$180.00 Processing fee under 37 CFR 1.17(p), or
(After the CFR 1.97 (b) time period, but before final action or notice of allowance, whichever occurs first)
- () under 37 CFR 1.97 (d) together with a:
() Statement under 37 CFR 1.97(e), and
() a \$180.00 processing fee under 37 CFR 1.17(p).
(Filed after final action or notice of allowance, whichever occurs first, but before payment of the issue fee)

Please charge to Deposit Account **50-1078** the sum of \$0.00 . At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account **50-1078** pursuant to 37 CFR 1.25.

() Applicant(s) submit herewith Form PTO 1449. References identified with an asterisk (*) were disclosed in Patent Application No. _____ filed _____, now U. S. Patent No. _____, and, as such, copies thereof are not included pursuant to the provisions of 37 CFR 1.98(d).

() A concise explanation of the relevance of foreign language patents, foreign language publications and other foreign language information listed on PTO Form 1449, as presently understood by the individuals(s) designated in 37 CFR 1.56 (c) most knowledgeable about the content is given on the attached sheet, or where a foreign language patent is cited in a search report or other action by a foreign patent office in a counterpart foreign application, an English language version of the search report or action which indicates the degree of relevance found by the foreign office is listed on form PTO 1449 and is enclosed herewith.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450.

Date of Deposit: Oct. 17, 2003

Typed Name: Katherine Lopez Diangson

Signature: 

Respectfully submitted,

Theil, et al

By 

Pamela Lau Kee

Attorney/Agent for Applicant(s)

Reg. No. 36,184

Date: Oct. 17, 2003

FORM PTO-1449

LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE
STATEMENT

(Use several sheets if necessary)

ATTY. DOCKET NO.

10021136-1

SERIAL NO.

10/615,522

APPLICANT

Theil, et al.

FILING DATE

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GROUP

2621

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	*	DOCUMENT NUMBER	DATE	NAME

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	NAME	TRANSLATION	
					YES	NO

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

	Harada, N. Uya, S., Hayashimot, Y. et al "A CCD Image Sensor Overlaid with an a-Si:H/a-SiC:H Photoconversion Layer Extended Abstracts of the 15th Conference on Solid State Devices and Materials 1983 pgs. 209-212
	Uya, S., Harada, N., Hayashimoto, Y., et al. "A High Resolution CCD Image Sensor Overlaid with an a-Si:H Photoconductive Layer." Extended Abstracts of the 16th (1984 International) Conference on Solid State Devices and Materials 1984 pgs. 325-328
	Harada, N. " A CCD Imager Overlaid with an a-Si: H Layer Amorphous Technologies & Devices 1984 pgs. 283-289

EXAMINER

DATE CONSIDERED

* Copies of these references are not enclosed pursuant to 37 CFR 1.98(d). (See accompanying IDS)

**PATENT APPLICATION**Sheet 2 of 2

FORM PTO-1449

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		Harada, N. Uya, S., Endo, Y. et al "A High-Resolution Staggered-Configuration CCD Imager Overlaid with an a-Si-H Photoconductive Layer." IEEE Transactions on Electron Devices, Vol. ED-32, No. 8 Aug 1985 1499-1504

EXAMINER

DATE CONSIDERED

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